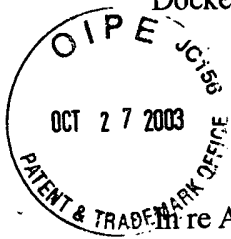


Docket No.: 2328-049

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Tuqiang NI

U.S. Patent Application No. 09/689,616

Filed: October 13, 2000

: : EXPEDITED PROCEDURE
: : Response under 37 CFR 1.116
:
:
: Group Art Unit: 1763
:
: Examiner: ALEJANDRO MULERO,
LUZ L.

For: ETCH CHAMBER WITH HYBRID PLASMA SOURCE

AMENDMENT UNDER RULE 116

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is submitted in reply to the Office Action mailed August 23, 2003, which was made Final. Applicants respectfully request that the following amendments **as to form** be entered to place this application in condition for allowance.

Certificate of Mailing

I hereby certify this correspondence is
being deposited with the United States Postal Service as
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Patents P.O. Box 1450 Alexandria, VA 22313-1450)

On

October 23 2003

Paul C.